

Notice of References Cited

Application/Control No.

10/544,210

Applicant(s)/Patent Under

Reexamination

TAKAHASHI ET AL.

Examiner

ADAM A. ARCIERO

Art Unit

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Page 1 of 1

U.S. PATENT DOCUMENTS

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
A	US-			
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NON-PATENT DOCUMENTS

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
U	IPDL PAJ JPO machine translation for JP 2002-358963, Yamazaki et al. (December 13, 2002)
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